IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF

FUJII et al.

Allowed: September 13, 2001

Batch No.: L96

Group Art Unit: 2856 Examine: Kwok

Appln. No.: 09/749,693

Filed: December 28, 2000

Title: SEMICONDUCTOR MECHANICAL SENSOR

Date: December 6, 2001

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents Washington, D.C. 20231

Sir:

Attached is Form PTO-1449 listing the enclosed.

I hereby certify that each enclosed document listed on the herewith Form PTO-1449 was cited in the attached Japanese Official Action sent November 20, 2001, issued in a counterpart foreign application not more than three months ago.

This IDS is intended to be in full compliance with the rules, but should the Examiner find any part of its required content to have been omitted, <u>prompt</u> notice to that effect is earnestly solicited, along with additional time under Rule 97(f), to enable Applicant to comply fully.

Consideration of the foregoing and enclosures plus the return of a copy of the enclosed Form PTO-1449 with the Examiner's initials in the left column per MPEP 609 are earnestly solicited along with an early action on the merits.

Respectfully submitted,

PILLSBURY WINTEROP LLF

ferry J. Dalley

Tel. No. (202) 905-2044 Fax No. (703) 905-2500

HJD/jjg 1600 Tysons Boulevard McLean, VA 22102

(703) 905-2000

30243760_1.DOC

IDS-B 10

9/3/01

